

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

) Art Unit: 1765

)

) Confirmation No.: 1669

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Applicants: Satoshi Komiya et al.

) I hereby certify that this correspondence is being  
) deposited with the United Postal Service as first class  
) mail in an envelope addressed to: Mail Stop PATENT  
) APPLICATION / Commissioner for Patents / P.O.  
) Box 1450 / Alexandria, Virginia 22313-1450, on  
) February 3, 2004

Serial No.: 10/679,031

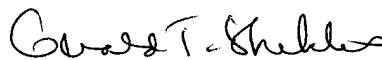
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Examiner: Not Yet Assigned

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Gerald T. Shekleton Reg. No. 27,466

**PRELIMINARY AMENDMENT**

Mail Stop PATENT APPLICATION  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Preliminary to the examination of the above application, please amend as follows: